Application/Control No. Applicant(s)/Patent Under Reexamination 10/605,140 CHOU ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Kim Huynh 2182 **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY Α US-6,507,881 01-2003 Chen, Joe 710/305 712/43 В US-5,872,994 02-1999 Akiyama et al. 03-2004 US-6,708,257 Bao, Liewei 711/154 С US-D US-Ε F US-US-G US-US-US-J US-Κ US-L US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Ρ Q R s Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U W

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